IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Jayachandran, et al.

Confirmation No.: To be assigned

Group Art Unit: To be assigned

Serial No.: 10/695,591

Examiner: To be assigned

Filed: October 28, 2003

Docket No.: 62020-1560

For: MICROSTRUCTURES AND METHODS OF FABRICATION THEREOF

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

This information disclosure statement is filed in accordance with 37 C.F.R. §§ 1.56, 1.97, and 1.98, and specifically:

	This information disclosure statement is fired in accordance with 37 C.I.K. §§ 1.30, 1.77, and 1.70, and appearance.			
	\boxtimes	under 37 CFR 1.97(b), or (within Three months of filing national application; or date of entry of international application; or before mailing date of first office action on the merits; whichever occurs last)		
		under 37 CFR 1.97(c) together with either a: Statement Under 37 C.F.R. 1.97(e), or a \$180.00 fee under 37 CFR 1.17(p), or (After the CFR 1.97(b) time period, but before the final office action or notice of allowance, whichever occurs first)		
		under 37 CFR 1.97(d) together with a: Statement under 37 CFR 1.97(e), and a \$180.00 petition fee set forth in 37 CFR 1.17(p). (Filed after final office action or notice of allowance, whichever occurs first, but before payment of the issue fee)		
endeno Commi	cy of this	d is a check in the amount of \$ Please charge \$ to deposit account . At any time during the sapplication, please charge any fees required to Deposit Account 20-0778 pursuant to 37 CFR 1.25. The hereby requested to credit any overpayment to Deposit Account No. 20-0778.		
⊠.	(where may or	ant(s) submit herewith Form PTO 1449A - Information Disclosure Statement by Applicant together with copies required) of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may not be material to the examination of this application and for which there may be a duty to disclose in new with 37 CFR 1.56. As required by 37 C.F.R. §1.98(a), a legible copy of each document is provided.		
	other fo CFR 1.3 cited in	se explanation of the relevance of foreign language patents, foreign language publications and reign language information listed on PTO Form 1449, as presently understood by the individual(s) designated in 37 56(c) most knowledgeable about the content is given on the attached sheet, or where a foreign language patent is a search report or other action by a foreign patent office in a counterpart foreign application, an English language of the search report or action which indicates the degree of relevance found by the foreign office is listed on the form		

The following rights are reserved by the Applicant(s): the right to establish the patentability of the claimed invention over any of the listed documents should they be applied as reference, and/or the right to prove that some of these documents may not be enabling for the teachings they purport to offer.

This statement should not be construed as a representation that an exhaustive search has been made, or that information more material to the examination of the present application does not exist. Any statements or identifications regarding the relevance of any portion(s) of cited references should not be construed as a representation that the most relevant portion(s) have been identified, and the absence of such statements or identifications should not be construed as representations that there are no relevant portion(s). The Examiner is specifically requested not to rely solely on the materials submitted herewith. The Examiner is requested to conduct an independent and thorough review of the documents, and to form independent opinions as to their significance.

It is requested that the information disclosed herein be made of record in this application and that the Examiner initial and return a copy of the enclosed PTO-1449 to indicate the documents have been considered.

Respectfully Submitted,

THOMAS, KAYDEN, HORSTEMEYER

& RISLEY, L.L.P.

By:

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CERTIFIED MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as "First Class Mail," in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on January 2004.

Signature/Jo Bryan

Form PTO-1449		Attorney Docket No.	Serial No.		
	•	062020-1560	10/695,591		
FER O 2 2004	MATION DISCLOSURE CITATION	Applicant Jayachandran, et al.			
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